Annication Number	4.07	1000000					
Application Number:	10:	10588698					
Filing Date:	08-	08-Aug-2006					
Title of Invention:		METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE AND METHOD OF ETCHING AN INSULATING FILM					
First Named Inventor/Applicant Name:	Tac	Tadahiro Ohmi					
Filer:	Ge	George C. Beck					
Attorney Docket Number:	039	039262-0156					
Filed as Small Entity							
U.S. National Stage under 35 USC 371 F	Filing Fee	5					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1055